	Application No.	Applicant(s)	
Notice of Allowability	09/507,212	YAMASHITA, SEIJI	
	Examiner	Art Unit	
	Thao T. Tran	1711	•
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) of NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIC of the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED or other appropriate comn GHTS. This application is	in this application. If not included	d
1. This communication is responsive to <u>4/30/04</u> .			
2. The allowed claim(s) is/are <u>10-13,26 and 27</u> .			
3. The drawings filed on 2/18/2000 are accepted by the Exami	ner.		
 4. Acknowledgment is made of a claim for foreign priority under a) All b) Some* c) None of the: 1. Certified copies of the priority documents have a copies of the priority documents have a copies of the certified copies of the priority documents have a copies of the certified copies of the priority documents have a copies of the certified copies of the priority documents have a copies of the certified copies of the priority documents have a copies of the certified copies of the priority documents have a copies of the priority documents have a	been received. been received in Applicati	ion No	on from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" o noted below. Failure to timely comply will result in ABANDONME THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	f this communication to file NT of this application.	e a reply complying with the requ	irements
 A SUBSTITUTE OATH OR DECLARATION must be submitted INFORMAL PATENT APPLICATION (PTO-152) which gives 	ted. Note the attached EX reason(s) why the oath o	AMINER'S AMENDMENT or NO declaration is deficient.	TICE OF
 CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftsperso 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in the DEPOSIT OF and/or INFORMATION about the depositatached Examiner's comment regarding REQUIREMENT FORMATION and the sheet of the comment of the comment regarding REQUIREMENT FORMATION and the comment r	n's Patent Drawing Review Amendment / Comment of 4(c)) should be written on to be header according to 37 City	or in the Office action of the drawings in the front (not the back 1.121(d).	
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08) Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ⊠ Interview S Paper No./ 7. ⊠ Examiner's	nformal Patent Application (PTO-1 summary (PTO-413), /Mail Date Amendment/Comment Statement of Reasons for Allowa	, .

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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Garth Janke on July 7, 2004.

The application has been amended as follows: claims 1, 3-4, 14, and 21 have been canceled.

Allowable Subject Matter

- 2. Claims 10-13 and 26-27 are allowed.
- 3. The following is an examiner's statement of reasons for allowance: no prior art has been found to teach, disclose, or fairly suggest an apparatus for reducing contamination of an article, comprising a coating on selected portion of the container, wherein the coating is consisting essentially of titanium dioxide; in combination with all of the other limitations of claim 10.

The prior art of Fuji et al. (US Pat. 6,395,240) is cited of interest. Fuji teaches a carrier box (an apparatus) for a semiconductor substrate or wafer, comprising a plastic container (synthetic resin) such as polycarbonate, which holds the semiconductor wafers (see abstract; Figs. 1-6; col. 5, ln. 47-59). The carrier box is equipped with a cleaning mechanism, which uses a photo-catalyst for cleaning inside the box (see col. 3, ln. 10-24; col. 4, ln. 1-2). The photocatalyst serves to remove gaseous contaminants and preferably made of a semiconductor

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material, such as TiO₂ alone or with other compounds (see col. 8, ln. 25-52). Fuji, however,

differs from the presently claimed invention in that the reference teaches the photo-catalyst to be

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coated on a plate that is attached to the container, and not coated on the container directly.

4. Any comments considered necessary by applicant must be submitted no later than the

payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

5. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Thao T. Tran whose telephone number is 571-272-1080. The

examiner can normally be reached on Monday-Friday, from 8:30 a.m. - 5:00 p.m..

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, James Seidleck can be reached on 571-272-1078. The fax phone number for the

organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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July 7, 2004

James J. Seidleck Supervisory Patent Examiner Technology Center 1700